



I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE
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(Date of Deposit)

Karen Cinq-Mars (Signature & Date)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of _____ : August 19, 2003
Caroline Boulenger _____ : Art Unit: 2822
Serial No. 09/756,997 _____ : Examiner: Christy L. Novacek
Filed: January 8, 2001 _____ : IBM Corporation
Title: METHOD FOR ELIMINATING
DEVELOPMENT RELATED DEFECTS
IN PHOTORESIST MASKS _____ : Dept. 18G/Bldg. 300-482
2070 Route 52,
New York 12533-6531

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TECHNOLOGY CENTER 2800

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Arlington, Va 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 CFR 1.56, and further pursuant to 37 CFR 1.97 and 37 CFR 1.98, Applicants hereby respectfully submit copies of the following documents as listed on Form PTO-1449, attached hereto.

Please charge any fees in connection with this statement to Deposit Account # 09-0458.

Respectfully submitted,

Joseph P. Abate 8-19-03
Joseph P. Abate, Attorney
Registration No. 30,238
Telephone No. (845)894-4633

JPA/kcm

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